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On August 29, 2006

TFCW 1745
PATENT
Attorney Docket No.: 085740-000000US

TOWNSEND and TOWNSEND and CREW LLP

By: Connie Larson
Connie Larson

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Menachem Nathan et al.

Application No.: 10/531,529

Filed: June 27, 2005

For: THIN-FILM CATHODE FOR 3-DIMENSIONAL MICROBATTERY AND METHOD FOR PREPARING SUCH CATHODE

Confirmation No.: 1927

Examiner:

Art Unit: 1745

INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR §1.97 and
§1.98

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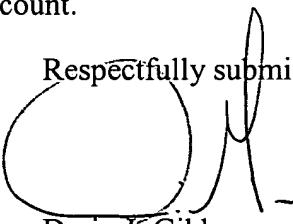
Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references [in compliance with the requirements of 37 CFR §1.98(a)(2)] are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

Also enclosed is a copy of the Search/Examination report corresponding to the PCT application. Document FR 2550 015 is not in the English language. A concise explanation of the relevance of document FR 2550 015 is found in the attached International Search Report.

As provided for by 37 CFR §1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Darin J. Gibby
Reg. No. 38,464

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60856532 v1

AUG 31 2006

PTO/SB/08A (07-05)



Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1	of	2	Attorney Docket Number	085740-000000US
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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA	US-6,197,450	3-2001	Peled et al.	
	AB	US-6,300,709	10-2001	DeVoe et al.	
	AC	US-6,260,388	7-2001	Borrelli et al.	
	AD	US-6,270,714	8-2001	Azran et al.	
	AE	US-5,162,178	11-1992	Ohsawa et al.	
	AF	US-5,338,625	8-1994	Bates et al.	
	AG	US-5,567,210	10-1996	Bates et al.	
	AH	US-6,214,161	4-2001	Becker et al.	
	AI	US-5,498,312	3-1996	Laermer et al.	
	AJ	US-6,303,512	10-2001	Laermer et al.	
	AK	US-			
	AL	US-			
	AM	US-			
	AN	US-			
	AO	US-			
	AP	US-			
	AQ	US-			
	AR	US-			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				
	AS	WIPO	WO 05/036711		4-2005			<input checked="" type="checkbox"/>
	AT	WIPO	WO 05/101973		11-2005			<input checked="" type="checkbox"/>
	AU	France	FR 2550015		1-1985		See Search Report	<input type="checkbox"/>
	AV	Europe	EP 0450848		10-1991			<input checked="" type="checkbox"/>
	AW	EP	EP 1134821 With Search Report		9-2001			<input checked="" type="checkbox"/>

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

60856532 v1



Substitute for form 1449B/PTO				Complete if Known	
				Application Number	10/531,529
				Filing Date	June 27, 2005
				First Named Inventor	Nathan, Menachem
				Art Unit	1745
				Examiner Name	
Sheet	2	of	2	Attorney Docket Number	085740-000000US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	BA	J.J. Devadasan, et al., Journal of Crystal Growth 226 (2001) 67-72.	<input type="checkbox"/>
	BB	P. Fragnaud, et al., Journal of Power Sources 54 (1995) 362-366.	<input type="checkbox"/>
	BC	I. Martin-Litas, et al., Journal of Power Sources 97-98 (2001) 545-547.	<input type="checkbox"/>
	BD	Long, et al., "Three-dimensional battery architectures", Chemical Review, Vol. 10, Number 104, October 2004.	<input type="checkbox"/>
	BE	Golodnitsky, et al., "Progress in three-dimensional (3D) Li-Ion microbatteries", The 15 th International Conference on Solid-State Ionics (SSI-15), Baden-Baden, Germany, July 17-22, 2005.	<input type="checkbox"/>
	BF	Albu-Yaron, et al., "Influence of the electrochemical deposition parameters on the microstructure of MoS ₂ thin films", Thin Solid Films, Elsevier-Sequoia S.A. Lausanne, CH. Vol. 361-362, no. 1, February 2000, pages 223-228.	<input type="checkbox"/>
	BG	U.S. Provisional Patent Application Number 60/418,718.	<input type="checkbox"/>
	BH	Y. Miki, et al., Journal of Power Sources 54 (1995) 508-510.	<input type="checkbox"/>
	BI	Norma R. de Tacconi, et al., J. Phys. Chem. (1996), 100, 18234-18239.	<input type="checkbox"/>
	BJ	E.A. Ponomarev, et al., Thin Solid Films 280 (1996) 86-89.	<input type="checkbox"/>

Examiner Signature		Date Considered
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